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U.S. DEPARTMENT OF COMMERCE  
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102685023

To the Honorable Commissioner

\_\_\_\_\_ed original documents or copy thereof.

1. Name of conveying party(ies):

Takashi KAITO

Additional name(s) of conveying party(ies) attached? ☐ Yes ☒ No

3. Nature of conveyance:

- ☒ Assignment ☐ Merger  
☐ Security Agreement ☐ Change of Name  
☐ Other \_\_\_\_\_

Execution Date: February 13, 2004

2. Name and address of receiving party(ies)

Name: SII NanoTechnology Inc.

Internal Address: \_\_\_\_\_

Street Address: 8, Nakase 1-chome, Mihama-ku  
Chiba-shi

City: Chiba State: JAPAN Zip: \_\_\_\_\_

Additional name(s) & address(es) attached? ☐ Yes ☒ No

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: \_\_\_\_\_

A. Patent Application No.(s) 10/001,333

B. Patent No.(s) \_\_\_\_\_

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Bruce L. Adams

Internal Address: \_\_\_\_\_

Street Address: 50 Broadway-31st Floor

City: New York State: NY Zip: 10004

6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41).....\$ 40.00

☒ Enclosed

☒ Authorized to be charged to deposit account  
any deficiency in enclosed fee

8. Deposit account number:

01-0268

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9. Signature.

Bruce L. Adams

Name of Person Signing

Signature

February 26, 2004

Date

Total number of pages including cover sheet, attachments, and documents: 3

Mail documents to be recorded with required cover sheet information to:

Commissioner of Patents & Trademarks, Box Assignment  
Washington, D.C. 20231

MAILING CERTIFICATE ON  
REVERSE SIDE OF PAGE

PATENT  
REEL: 015029 FRAME: 0270

**ASSIGNMENT**

WHEREAS, I, Takashi Kaito, residing at c/o SII NanoTechnology Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan have invented new and useful improvements in \_\_\_\_\_  
BEAM SHAPED FILM PATTERN FORMATION METHOD

for which I have prepared an application for Letters Patent of the United States of America;

AND WHEREAS, SII NanoTechnology Inc., located and doing business at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor;

NOW, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to me in hand paid, the receipt of which is hereby acknowledged, I have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said SII NanoTechnology Inc. for the territory of the United States of America, my entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by me on December 13, 2001, filed October 26, 2001, Serial No. 10/001,333, preparatory to obtaining Letters Patent thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said SII NanoTechnology Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by me had this assignment, sale and transfer not been made.

AND, I hereby covenant and agree that I will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and I hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said ~~XXXXXXXXXXXXXXXXXXXX~~.  
SII NanoTechnology Inc.  
in accordance with this assignment.

Executed this 13<sup>th</sup> day of February, 2004 at

\_\_\_\_\_.

Witness:

Masaki HORI  
Masaki HORI

Takashi Kaito (L.S.)  
Takashi Kaito